

REMARKS

Claims 102-134 are pending in the application. Reconsideration of the application is requested in view of the remarks to follow.

The Examiner has required restriction between:

Group I: Claims 102-124, 126-131, 133-134; and

Group II: Claims 125 and 132.

Applicants elect the claims of Group I, and note that the listing above identifies claims readable thereon. Applicants note that the Examiner has identified claims 102 and 129 as being generic. Applicants also note that the Examiner states that upon allowance of a generic claim, Applicants are entitled to consideration of claims to additional species.

The Examiner indicates that the phrase "between the plates" appears to be without support in the specification. Applicants note that plasma processing parameters can be described in terms of specific powers and the like, which requires some description of geometry in order to be reproducible, or in terms of fields, power densities and the like. In the instant application, description is in terms of applied power and geometry.

Applicants note that the description given on p. 11, line 16 et seq. includes an analogous description of a plasma process. The description on p. 8 was amended to provide the public with clearer notice of the process that Applicant is teaching and to make the descriptions on pp. 8 and 11 more nearly parallel. However, in the event that the Examiner feels that the public

is better served by elision of this description, Applicants are willing to delete this explanatory text.

The Examiner also indicates that the correction of the obvious typographical error "a whole of all" to --the whole or all-- introduces new matter. Again, if the Examiner is of the opinion that the public is better served by inclusion of typographical errors, and the elision of corrections of obvious typographical errors, Applicants are willing to delete this explanatory correction to the text.

Further, Applicant herewith submits duplicate copies of the Supplemental Information Disclosure Statements and Form PTO-1449s filed in this application on September 25, 2001, March 5, 2002 and April 26, 2002, respectively. No initialed copies of the PTO-1449s have been received back from the Examiner. To the extent that the submitted references listed on the Form PTO-1449s have not already been considered, and the Form PTO-1449s have not been initialed with copies being returned to Applicant, such examination and initialing are requested at this time, as well as return of copies of the initialed Form PTO-1449s to the undersigned.


Attached hereto is a marked-up version of the changes made to the specification and claims by the current amendment. The attached page(s) are captioned "**Version with markings to show changes made.**"

In view of the foregoing, allowance of claims 102-134 is requested. The Examiner is requested to phone the undersigned in the event that the next Office Action is one other than a Notice of Allowance. The undersigned is

available for telephone consultation at any time during normal business hours
(Pacific Time Zone).

Respectfully submitted,

Dated: May 1, 2002

By: 
Frederick M. Fliegel, Ph.D.
Reg. No. 36,138

Version with markings to show changes made

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/388,826
Filing Date September 1, 1999
Inventor Weimin Li et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner E.J. Kielin
Attorney's Docket No. MI22-1208
Title: Low k Interlevel Dielectric Layer Fabrication Methods

37 CFR § 1.121(b)(1)(iii) AND 37 CFR § 1.121(c)(1)(ii)
FILING REQUIREMENTS TO ACCOMPANY RESPONSE TO
MAY 1, 2002 OFFICE ACTION

Deletions are bracketed, additions are underlined.

In the Claims

There are no amendments to the claims.

END OF DOCUMENT